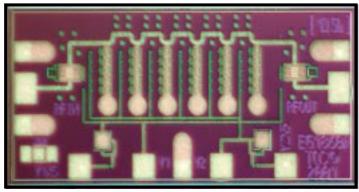




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# **50 GHz Wideband Analog Attenuator**

#### TGL4203-EPU



Chip Dimensions 1.7mm x 0.8 mm x 0.1mm

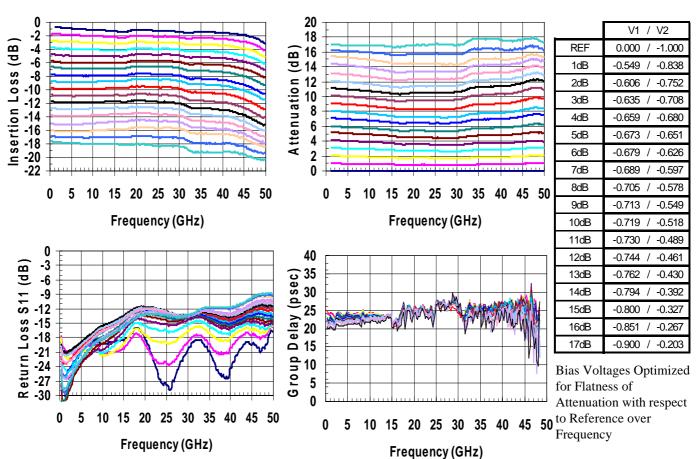
#### **Key Features and Performance**

- 0.25um 3MI MMW pHEMT
- Broadband Response DC to > 50 GHz
- 2dB typical Insertion Loss
- 17dB Variable Attenuation Range
- 15dB typical Return Loss
- Bias: -1V to 0V

# **Primary Applications**

- Point to Point Radio
- Fiber Optic
- Wideband Military & Space

### **Typical Electrical Characteristics**





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# TABLE I MAXIMUM RATINGS 1/

SYMBOL	PARAMETER	VALUE	NOTES
	Attenuation Control Voltage Range	-5 to +1 V	
I <sub>G1</sub>	Gate 1 Supply Current	2.2 mA	
I <sub>G2</sub>	Gate 2 Supply Current	19.8 mA	
P <sub>IN</sub>	Input Continuous Wave Power	> 30dBm	
$P_D$	Power Dissipation	TBD	
T <sub>CH</sub>	Operating Channel Temperature	150 °C	<u>2</u> / <u>3</u> /
$T_M$	Mounting Temperature (30 Seconds)	320 °C	
T <sub>STG</sub>	Storage Temperature	-65 to 150 °C	

- 1/ These ratings represent the maximum operable values for this device.
- <u>2</u>/ Junction operating temperature will directly affect the device median time to failure (T<sub>M</sub>). For maximum life, it is recommended that junction temperatures be maintained at the lowest possible levels.
- 3/ These ratings apply to each individual FET.

# TABLE II ELECTRICAL CHARACTERISTICS

(Ta = 25°C Nominal)

PARAMETER		TEST CONDITIONS	TYP	UNIT
	Attenuation Control Voltage	DC ~ 50 GHz	-1 to 0	V
IL	Insertion Loss	DC ~ 50 GHz	2	dB
	Maximum Attenuation	DC ~ 50 GHz	17	dB
IRL	Input Return Loss	DC ~ 50 GHz	15	dB
ORL	Output Return Loss	DC ~ 50 GHz	15	dB
Pin1dB	Input Power @ 1dB Atten. Change	5 to 25 GHz	*	dBm
	Group Delay Variation	DC ~ 50 GHz	+/-5	psec
	Max. Insertion Loss Ripple (peak to peak)	DC ~ 50 GHz	0.5	dB

<sup>\*</sup> Pin1dB varies depending on Attenuation State and frequency. See graphs on page 3 for details

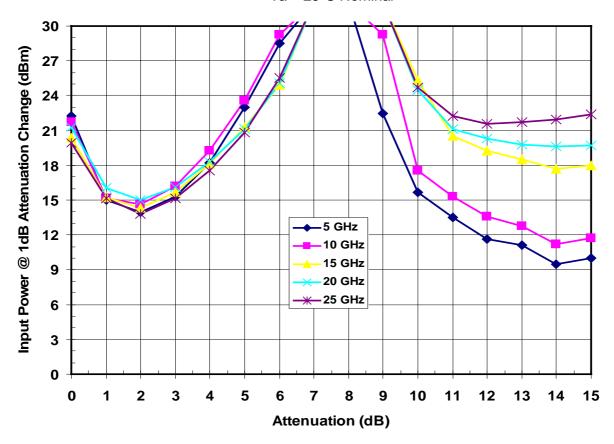


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# Typical Pin1dB vs Attenuation

Ta = 25°C Nominal

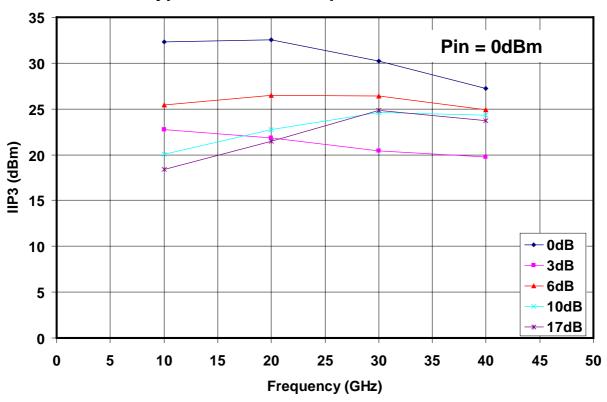


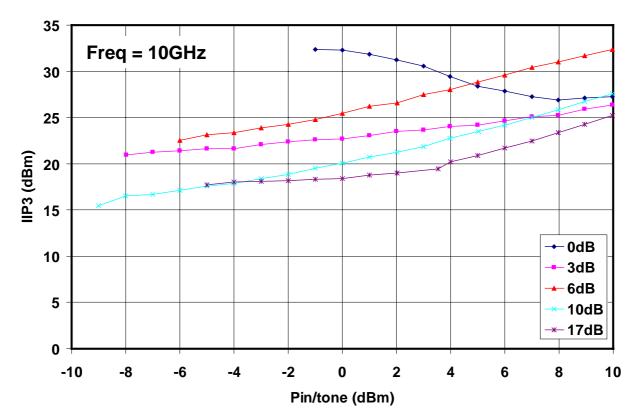


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#### **Typical Attenuator Input TOI vs. Attenuation**



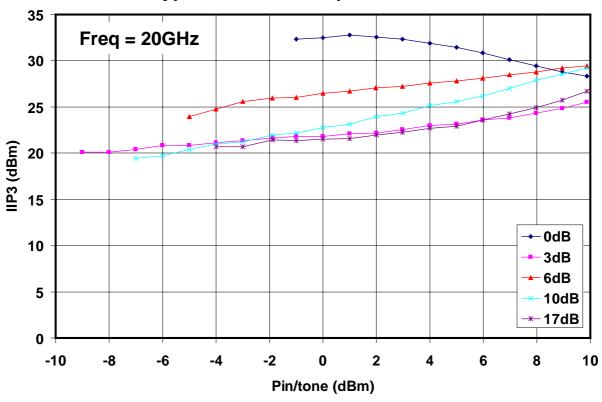


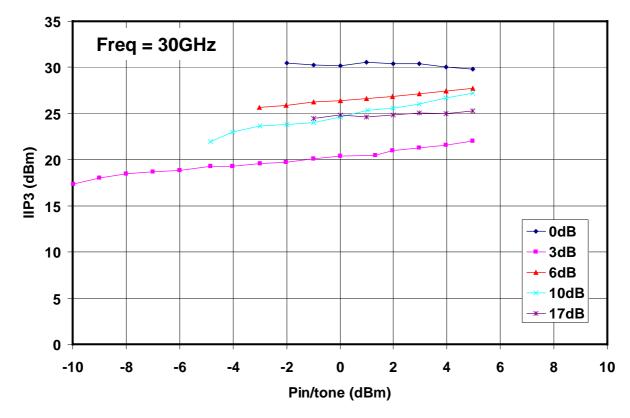


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# **Typical Attenuator Input TOI vs. Attenuation**



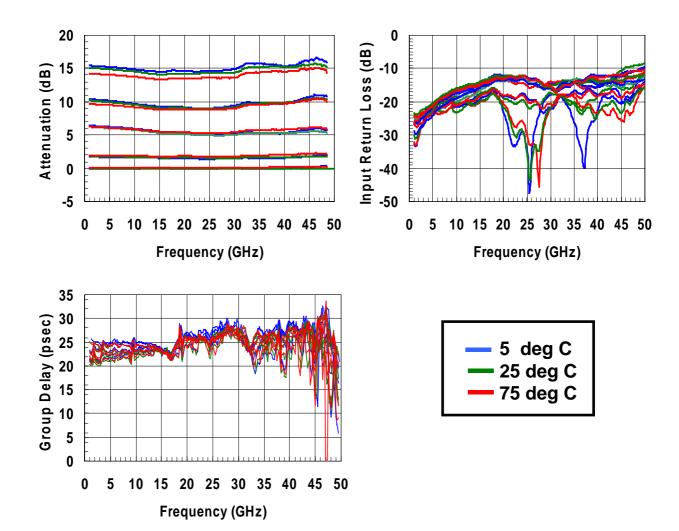




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#### **Typical Measurement Over Temperature**

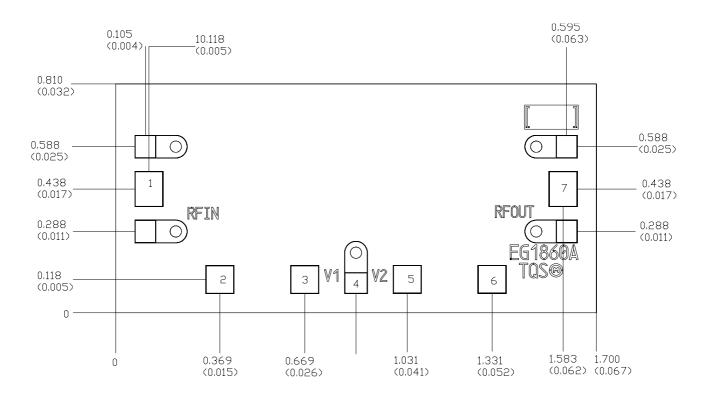




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## **Mechanical Drawing**



Units: millimeters (inches)
Thickness: 0.100 (0.004)
Chip edge to bond pad dimensions are shown to center of bond pad
Chip size tolerance: +/- 0.051 (0.002)

(RF In) (NC) Bond pad #1  $0.100 \times 0.125$  $(0.004 \times 0.005)$ Bond pad #2  $0.100 \times 0.100$  $(0.004 \times 0.004)$  $0.100 \times 0.100$ Bond pad #3 (VG1)  $(0.004 \times 0.004)$ Bond pad #4 (DC GND)  $0.081 \times 0.075$  $(0.003 \times 0.003)$ Bond pad #5 (VG2)  $0.100 \times 0.100$  $(0.004 \times 0.004)$ Bond pad #6 (NC)  $0.100 \times 0.100$  $(0.004 \times 0.004)$ (RF Dut) Bond pad #7  $0.100 \times 0.125$  $(0.004 \times 0.005)$ 

RF GND is back side of MMIC

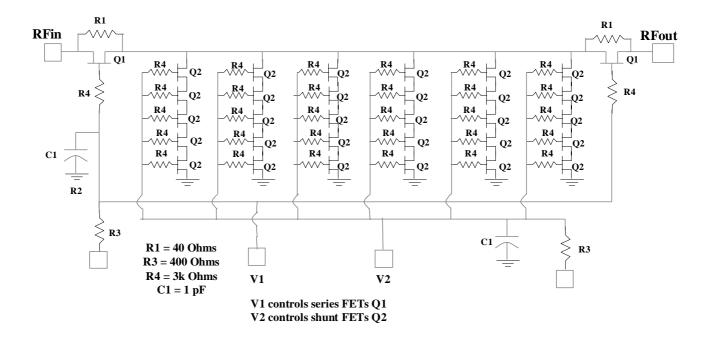
GaAs MMIC devices are susceptible to damage from Electrostatic Discharge. Proper precautions should be observed during handling, assembly and test.



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#### **DC Schematic**



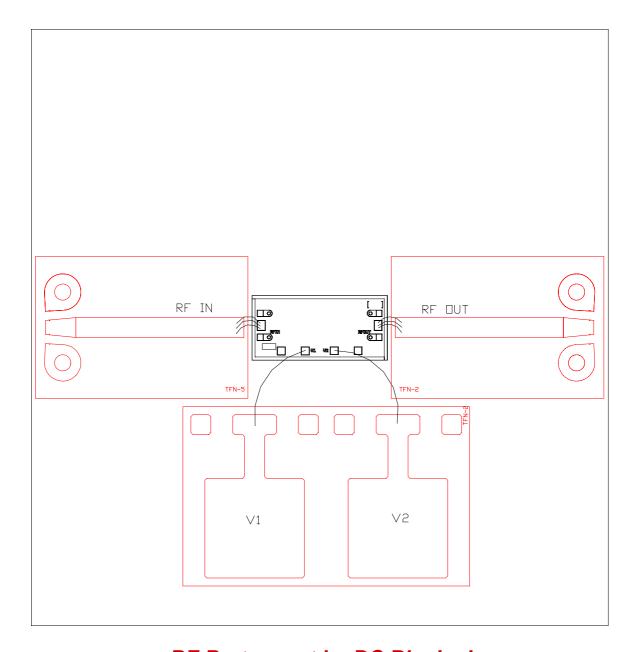
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# **Chip Assembly Diagram**



RF Ports must be DC Blocked

GaAs MMIC devices are susceptible to damage from Electrostatic Discharge. Proper precautions should be observed during handling, assembly and test.



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## **Assembly Process Notes**

#### Reflow process assembly notes:

- Use AuSn (80/20) solder with limited exposure to temperatures at or above 300 C (30 seconds max).
- An alloy station or conveyor furnace with reducing atmosphere should be used.
- No fluxes should be utilized.
- Coefficient of thermal expansion matching is critical for long-term reliability.
- Devices must be stored in a dry nitrogen atmosphere.

#### Component placement and adhesive attachment assembly notes:

- Vacuum pencils and/or vacuum collets are the preferred method of pick up.
- Air bridges must be avoided during placement.
- The force impact is critical during auto placement.
- Organic attachment can be used in low-power applications.
- Curing should be done in a convection oven; proper exhaust is a safety concern.
- Microwave or radiant curing should not be used because of differential heating.
- Coefficient of thermal expansion matching is critical.

#### Interconnect process assembly notes:

- Thermosonic ball bonding is the preferred interconnect technique.
- Force, time, and ultrasonics are critical parameters.
- · Aluminum wire should not be used.
- Discrete FET devices with small pad sizes should be bonded with 0.0007-inch wire.
- Maximum stage temperature is 200 □ C.

GaAs MMIC devices are susceptible to damage from Electrostatic Discharge. Proper precautions should be observed during handling, assembly and test.